



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Li et al.

Serial No.: 10/709,212

Filed: April 21, 2004

For: Directional Electromagnetic Wave Resistivity Apparatus
And Method

) Docket No.: 20.2886

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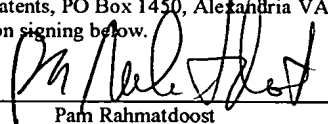
) Group Art Unit: 2862

)

) Confirmation No. 3211

)

) Examiner:

CERTIFICATE OF MAILING
I hereby certify that this correspondence (along with any document referenced as being attached or enclosed hereto) is being deposited with the United States Postal Service in an envelope as First Class Mail addressed to: Commissioner for Patents, PO Box 1450, Alexandria VA 22313-1450 on this date by the person signing below.

Pam Rahmatdoost Date 5/13/04

Commissioner for Patents
PO Box 1450
Alexandria VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

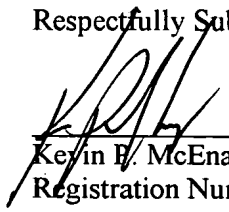
The following documents on the Form PTO-1449 are submitted to the United States Patent and Trademark Office under provisions of 37 CFR 1.97-1.98. A copy of each reference is enclosed.

Please charge any necessary fees to the deposit account for Schlumberger Technology Corporation, Account No. 19-0610.

Respectfully Submitted,

Date:

May 12, 2004


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FORM PTO-1449 (Modified)

ATTY. DOCKET NO.
20.2886SERIAL NO.
10/709,212LIST OF INFORMATION PROVIDED
BY APPLICANT

(Use several sheets if necessary)

APPLICANT: Li et al.

FILING DATE:
04/21/04GROUP
2862

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Patentee
	AA			
	AB			
	AC			
	AD			
	AE			
	AF			
	AG			
	AH			
	AI			

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation	
					Yes	No
	AL					
	AM					
	AN					
	AO					

OTHER INFORMATION PROVIDED (AUTHOR, TITLE, DATE, PLACE OF PUBLICATION, PERTINENT PAGES, ETC.)

	AR	I.R. Tribe et al., "Precise Well Placement using Rotary Steerable Systems and LWD Measurements," SPE 71396, SPE Annual Technical Conference and Exhibition, New Orleans, LA, Sept. 30, 2001 - October 3, 2001
	AS	
	AT	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

1. The attached cited information should not be construed as an admission that any of the above items are prior art to the subject invention.

